



TFW

Docket No.: SANZ 254
(10403677)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re
Application of: Richert, et al.

Serial No.: 10/806,060

Group Art Unit:

Filed: May 22, 2004

Examiner:

For: METHOD FOR OPERATING AN IN-LINE
COATING INSTALLATION

May 19, 2004

TRANSLATION OF RELEVANT PORTIONS OF DE 200 22 564 U1

Commissioner for Patents
P. O. Box 1450
Alexandria, VA. 22313-1450

Dear Sir:

Below is a translation of the relevant portion of DE 200 22 564 U1 which was filed with an Information Disclosure Statement filed March 22, 2004.

Arrangement for the defect-free coating of substrates with a coating distance, which includes at least one vacuum coating section, further including an entrance and an exit interlock and at least one one-part carrier or one multipart carrier consisting of a carrier insert for receiving the substrates and a carrier support receiving the carrier insert, whereby the carrier support can be passed on a carrier path through the coating arrangement between the entrance and the exit interlock, further including a carrier return between the exit and the entrance interlock, characterized in that the carrier return is formed by at least part of the coating arrangement (6) and in that the carrier path (5) is implemented as a closed path.

Serial No.

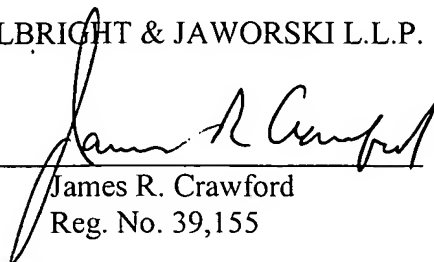
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If any fees are due for entry of this communication, authorization is given to charge deposit account no: 50-0624.

Respectfully submitted,

FULBRIGHT & JAWORSKI L.L.P.

By

A handwritten signature in dark ink, appearing to read "James R. Crawford", is written over a horizontal line.

James R. Crawford

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Enclosures